

## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Shinichi FUKADA Group Art Unit: 2811

Application No.: 10/849,016

Filed: May 20, 2004 Docket No.: 119798

For: SEMICONDUCTOR DEVICE AND METHOD FOR MANUFACTURING THE SAME

## **INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- 2. Relevance of the non-English language reference is discussed in the present specification.
- 3. An English-language Abstract of the non-English language reference is attached hereto.

 $\boxtimes$ 

4. A computer-generated English translation of the following Japanese reference has been obtained from the website of the Japanese Patent Office (http://www.jpo.go.jp), and is attached, but has not been reviewed for accuracy.

Respectfully submitted,

ames/A. Oliff

Registration No. 27,075

John S. Kern

Registration No. 42,719

JAO:JSK/tea

Date: August 24, 2004

OLIFF & BERRIDGE, PLC P.O. Box 19928 Alexandria, Virginia 22320 Telephone: (703) 836-6400 DEPOSIT ACCOUNT USE
AUTHORIZATION
Please grant any extension
necessary for entry;
Charge any fee due to our
Deposit Account No. 15-0461

AUG 2 4 2004 33

Sheet 1 of 1

Form PTO-1449 (REV. 8-83)	US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 119798			APPLICATION NO. 10/849,016		
INFORMATION DISCLOSURE STATEMENT								
(Use several sheets if necessary)			APPLICANT(S) Shinichi FUKADA					
			ING DATE y 20, 2004		GROUP 2811			
U.S. PATENT DOCUMENTS								
EXAMINER INITIAL	DOCUMENT NUMBER	DAT	DATE			CLASS	SUB CLASS	
							,	
FOREIGN PATENT DOCUMENTS								
	DOCUMENT NUMBER	DATI	<u> </u>	COUNTRY		CLASS	SUB CLASS	
		05/02/19				CLASS	CLASS	
		<u></u>	1			<del>                                     </del>		
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)								
			····					
					<del></del>			
						<del></del>		
•								
EXAMINER	<del></del>			DATE CONSIDERED				
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in								

Date: August 24, 2004